

TEW 1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Kenneth G. Flugaur et al.

Serial No.:

09/460,638

Title:

CHANNEL SLEEVE, IMPROVED PLASMA PROCESSING

CHAMBER CONTAINING CHANNEL SLEEVE AND

METHODS OF MAKING AND USING THE SAME

Filed:

December 14, 1999

Attorney Docket No.:

0325.00324

Examiner:

Zervigon, R.

Art Unit:

1763

In Response To:

Decision on Appeal mailed December 20, 2005

CERTIFICATE OF MAILING

I hereby certify that this letter, the response or amendment attached hereto are being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on February 10, 2006.

Jan M. Dunbar

AMENDMENT PURSUANT TO 37 CFR §41.50(b)(1)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the new ground for rejection presented in the Decision on Appeal mailed December 20, 2005, please amend the above-identified application as follows: